

Title (en)
ELECTROLYTIC CAPACITORS AND METHOD FOR MAKING THEM

Title (de)
ELEKTROLYTKONDENSATOREN UND VERFAHREN ZU IHRER HERSTELLUNG

Title (fr)
CONDENSATEURS ELECTROLYTIQUES ET LEUR PROCEDE DE FABRICATION

Publication
EP 1382048 A4 20080528 (EN)

Application
EP 02700547 A 20020221

Priority

- IL 0200140 W 20020221
- IL 14159201 A 20010222

Abstract (en)

[origin: WO02067278A2] A method for making an integrated electrolytic capacitor, wherein a substrate is coated with at least one sequence of each of the following layers: a vacuum deposited film having a high specific surface area, which is selected from the group consisting of valve metals and mixtures of valve metals with valve metal oxides; superimposed on the film having a high specific surface area, at least one dielectric film comprising a substance selected from the group consisting of valve metal oxides, their complex oxides with at least one rare earth metal and their complex oxides with at least one alkaline earth metal; and a solid electrolyte film superimposed on the at least one film.

[origin: WO02067278A2] A method for making an integrated electrolytic capacitor wherein a substrate (40) is coated with at least one sequence of each of the following layers: a vacuum deposited film (42) having a high specific surface area, which is selected from the group consisting of valve metals and mixtures of valve metals with valve metal oxides; superimposed on the film having a high specific surface area, at least one dielectric film (46) comprising a substance selected from the group consisting of valve metal oxides, their complex oxides with at least one rare earth metal and their complex oxides with at least one alkaline earth metal; and a solid electrolyte film (48) superimposed on the at least one film.

IPC 1-7
H01G 9/042; **H01G 9/15**; **H05K 1/16**

IPC 8 full level
H01G 9/07 (2006.01); **H01G 4/33** (2006.01); **H01G 9/00** (2006.01); **H01G 9/04** (2006.01); **H01G 9/042** (2006.01); **H01G 9/055** (2006.01); **H01G 9/15** (2006.01); **H01L 21/02** (2006.01); **H05K 1/16** (2006.01)

CPC (source: EP)
H01G 9/042 (2013.01); **H01G 9/15** (2013.01); **H01L 28/40** (2013.01); **H05K 1/162** (2013.01); **H01G 9/0032** (2013.01); **H01G 9/0036** (2013.01); **H05K 2203/0315** (2013.01)

Citation (search report)

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- See references of WO 02067278A2

Designated contracting state (EPC)
AT BE CH CY DE DK ES FI FR GB GR IE IT LI LU MC NL PT SE TR

DOCDB simple family (publication)
WO 02067278 A2 20020829; **WO 02067278 A3 20021227**; AU 2002233612 A1 20020904; EP 1382048 A2 20040121; EP 1382048 A4 20080528; IL 141592 A0 20020310; IL 141592 A 20070211; JP 2004524686 A 20040812; JP 4390456 B2 20091224

DOCDB simple family (application)
IL 0200140 W 20020221; AU 2002233612 A 20020221; EP 02700547 A 20020221; IL 14159201 A 20010222; JP 2002566510 A 20020221